



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Richard Schenker et al. Art Unit: Unknown Serial No.: 10/813,453 Examiner: Unknown

Filed: March 29, 2004 Assignee: Intel Corporation

Title : LITHOGRAPHY USING CONTROLLED POLARIZATION

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicants call attention to the attached Information
Disclosure Statement and documents listed on form PTO-1449.

This filing is being made before the receipt of a first Office Action on the merits and within three months of the filing date of the application. No fee is required.

The documents are in the English language; hence no concise explanation is necessary per Rule 98(a)(3).

Consideration of the foregoing and enclosures plus the return of a copy of the enclosed form PTO-1449 with the

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Examiner's initials in the left column per MPEP 609 are earnestly solicited along with an early action on the merits.

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Respectfully submitted,

Date: June 18, 2004

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Form PTO-1449

U.S. Department of Commerce Patent and Trademark Office

Attorney's Docket No. 10559-928001

Application No. 10/813,453

Information Disclosure Statement by Applicant (Use several sheets if necessary)

Applicant Richard Schenker et al.

Filing Date

Group Art Unit

March 29, 2004

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

	Foreign Patent Documents or Published Foreign Patent Applications							
Examiner	Desig.	Document	Publication	Country or	- 1		Trans	slation
Initial	ID	Number	Date	Patent Office	Class	Subclass	Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

	Other Documents (include Author, Title, Date, and Place of Publication)				
Examiner	Desig.				
Initial	ID	Document			
	AQ	Adam et al., "Polarization Effects in Immersion Lithography," Proc. of SPIE, Vol. 5377, pp. 329-342 (2004)			
	AR				
	AS				
	AT				

Date Considered				
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with				
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